



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

January 27, 2025	
IGI Report Number	LG675578408
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUT CORNERED RECTANGULAR MODIFIED BRILLIANT
Measurements	7.01 X 4.93 X 3.42 MM

GRADING RESULTS

Carat Weight	1.09 CARAT
Color Grade	FANCY LIGHT YELLOW
Clarity Grade	VS 1

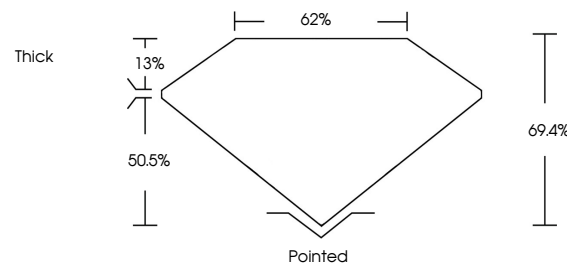
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	VERY GOOD
Fluorescence	NONE
Inscription(s)	15 LG675578408

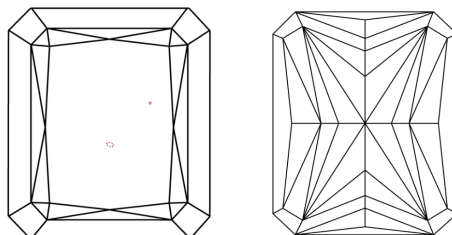
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

LG675578408
Report verification at lgi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

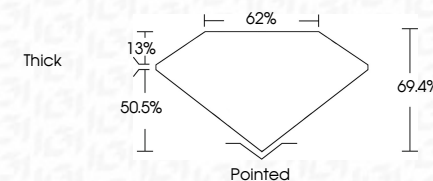
IF VWS¹⁻² VS¹⁻² SI¹⁻² I¹⁻³

Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included
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www.igi.org

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